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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: the application of

Redeker et al.

Application No. 10/734,704

Filed: December 12, 2003

For: METHOD AND APPARATUS FOR
SEMICONDUCTOR WAFER PLANARIZATION

Examiner: Dang, Trung Q.

Art Unit: 2823

Docket No. LAM2P461

Date: March 25, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 25, 2005.

Signed: Liisa Kreik

Liisa Kreik

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Alexandria, VA 22313-1450

Dear Sir:

Please note that this response to the Restriction Requirement dated February 24, 2005, is being submitted within the 30 day period for reply extending to March 28, 2005. In response to the Restriction Requirement, Applicants elect without traverse Group I (claims 1-9), to prosecute in the above-identified patent application. Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number below.

Respectfully submitted,
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